3

Notice of Allowability	Application No.	Applicant(s)	
	09/439,314	SANDHU ET AL.	
	Examiner	Art Unit	
	Parviz Hassanzadeh	1763	
The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.			
 This communication is responsive to 9/14/03. The allowed claim(s) is/are 41-69. The drawings filed on 12 November 1999 are accepted by Acknowledgment is made of a claim for foreign priority ur a) ☐ All b) ☐ Some* c) ☐ None of the: 1. ☐ Certified copies of the priority documents have 2. ☐ Certified copies of the priority documents have 3. ☐ Copies of the certified copies of the priority do International Bureau (PCT Rule 17.2(a)). * Certified copies not received: Acknowledgment is made of a claim for domestic priority up 	nder 35 U.S.C. § 119(a)-(d) of the been received. be been received in Application currents have been received.	n No d in this national stage applicat	
 5. Acknowledgment is made of a claim for domestic priority under 35 U.S.C. § 119(e) (to a provisional application) since a specific reference was included in the first sentence of the specification or in an Application Data Sheet. 37 CFR 1.78. (a) The translation of the foreign language provisional application has been received. 6. Acknowledgment is made of a claim for domestic priority under 35 U.S.C. §§ 120 and/or 121 since a specific reference was included in the first sentence of the specification or in an Application Data Sheet. 37 CFR 1.78. 			
Applicant has THREE MONTHS FROM THE "MAILING DATE" of below. Failure to timely comply will result in ABANDONMENT of 7. A SUBSTITUTE OATH OR DECLARATION must be subm	this application. THIS THR itted. Note the attached EXA	EE-MONTH PERIOD IS NOT I	EXTENDABLE.
INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient. 8. CORRECTED DRAWINGS (as "replacement sheets") must be submitted. (a) including changes required by the Notice of Draftsperson's Patent Drawing Review (PTO-948) attached 1) hereto or 2) to Paper No (b) including changes required by the proposed drawing correction filed, which has been approved by the Examiner. (c) including changes required by the attached Examiner's Amendment / Comment or in the Office action of Paper No			
Identifying indicia such as the application number (see 37 CFR 1.84(c)) should be written on the drawings in the front (not the back) of each sheet. Replacement sheet(s) should be labeled as such in the margin according to 37 CFR 1.121(d).			
9. DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL.			
Attachment(s)			
 1 Notice of References Cited (PTO-892) 2 Notice of Draftperson's Patent Drawing Review (PTO-948) 3 Information Disclosure Statements (PTO-1449 or PTO/SB/08 Paper No	6∐ Interview Sur), 7∐ Examiner's A	ormal Patent Application (PTO- mmary (PTO-413), Paper No mendment/Comment statement of Reasons for Allow	·

Application/Control Number: 09/439,314

Art Unit: 1763

DETAILED ACTION

Allowable Subject Matter

Claims 41-69 are allowed.

The following is an examiner's statement of reasons for allowance: a plasma processing system including a plasma processing reactor coupled to a plasma chamber, wherein the plasma reactor is configured to initially generate a plasma therein, further *configured to lose an ability to generate the plasma*, and configured to receive plasma from the plasma chamber coupled thereto and wherein the *plasma chamber is configured to restore the ability of the reactor to generate plasma*.

Neither of the prior art of the record teaches or suggests coupling a remote plasma source to an inductively coupled plasma reactor which is *configured to deposit a metal layer* on a substrate and wherein the *remote plasma source is further configured to remove metal deposit from the reactor*.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Parviz Hassanzadeh whose telephone number is (703)308-2050. The examiner can normally be reached on Tuesday-Friday.

Application/Control Number: 09/439,314

Art Unit: 1763

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Gregory Mills can be reached on (703)308-1633. The fax phone number for the organization where this application or proceeding is assigned is (703)872-9306.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703)308-0661.

Parviz Hassanzadeh Primary Examiner Art Unit 1763 Page 3

November 7, 2003